

**To:** ALL FIELD

**Date:** 6/29/2018

**Notice Number:** OSP20180629B

**Subject:** PRODUCT CHANGE NOTICE

Renesas is changing the wafer fabrication plant and wafer aperture. From the current Shiga plant with 6 inch wafers to Naka plant or Kawashiri plant with 8 inch wafers. [New wafer shipments will begin in Q3 2019.](#)

PCN#	Release Date dd-mmm-yy	Renesas Part Number	Comments
OSP20180629B	29-Jun-18	PS2502-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2502-4-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2502L-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2502L-1-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2502L-4-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2503-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2503L-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2503L-1-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2506-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2506L-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2506L-1-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2514-1Y-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2514L-1Y-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2514L-1Y-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2514L-1Y-V-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2562-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2562-1-V-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2562L-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2562L-1-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2562L2-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2702-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2702-1-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2702-1-V-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2702-1-V-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2706-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2706-1-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2802-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2802-1-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2802-4-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2802-4-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2806-1-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2806-1-F3-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2806-4-A	Wafer site change and wafer size change from 6" to 8"
OSP20180629B	29-Jun-18	PS2806-4-F3-A	Wafer site change and wafer size change from 6" to 8"